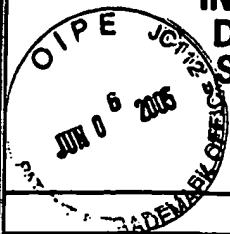



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|---|---------------------------------|-----------------------------------|
|  <p style="font-size: 1.2em; font-weight: bold;">INFORMATION DISCLOSURE STATEMENT</p> | Complete if known | |
| | Application Number: 10/076,858 | |
| | Filing Date: February 14, 2002 | |
| | First Named Inventor: Steinberg | |
| | Group Art Unit: 1775 | |
| | Examiner Name: Stephen J. Stein | |
| SHEET 1 OF 1 | | Attorney Docket Number: R&H 03-19 |

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| EXAMINER'S INITIALS | CITE NO. | DOCUMENT NUMBER | COUNTRY OR REGION | DATE OF PUBLICATION MM-DD-YYYY | FIRST NAMED INVENTOR OR APPLICANT |
| | | | | | |

| OTHER PRIOR ART - NON-PATENT DOCUMENTS | | |
|--|----------|---|
| EXAMINER'S INITIALS | CITE NO. | Include name of the author (in Capital Letters), title of the article (when appropriate), title of the item(book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published |
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| | | Nijdam, et al. "Etching of silicon in alkaline solutions: a critical look at the {111} minimum," MESA |
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|----------------------|---|-----------------|-----------|
| EXAMINER'S SIGNATURE |  | DATE CONSIDERED | 6/12/2005 |
|----------------------|---|-----------------|-----------|

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP §609. Draw a line through citation if citation not in conformance and reference not considered. Include a copy of this form with next communication to applicant.